

2
7-9-01
mccul



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Katsunori NISHI et al.)
Japanese Priority Application No. 2000-080242) Attn: Applications
Japanese Priority Date: March 22, 2000) Branch
For: SEMICONDUCTOR DEVICE AND)
METHOD OF FABRICATING THE SAME) Date: March 21, 2001

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents
Washington, D.C. 20231


Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

Copies of these references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Japanese Publication No. 11-501463 corresponds to PCT Publication No. WO 97/24752.

Respectfully submitted,


Eric J. Robinson
Registration No. 38,285

NIXON PEABODY LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 790-9110